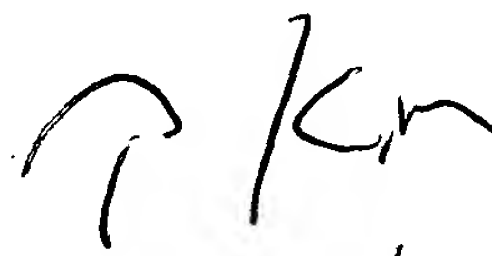|	L #	Hits	Search Text
1	L1	319	(test near3 (reticle or mask or quartz or monitor)) same (focus$3 or level$4 or z or position$4 or locat$4) same (object or substrate or wafer)
2	L2	6564	(reticle or mask or quartz or monitor) same (opaque and transparent)
3	L3	401	(test near3 (reticle or mask or quartz or monitor)) same (focus$3 or level$4 or z or position$4 or locat$4) same (object or substrate or wafer)
4	L4	36	2 and 3
5	L5	6692	(reticle or mask or quartz or monitor) same (phase near5 (chang$3 or shift$3))
6	L6	14	4 and 5
7	L7	179	test with (reticle or mask or quartz or monitor) with focus$3
8	L8	12	2 and 5 and 7
9	L9	8	8 not 6

P Km
6/4/03